

**PATENT**  
Attorney Docket No. 401384

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

KAZUHIRO TANAKA

Application No. 09/965,803

Filed: October 1, 2001

Art Unit: 1763

Examiner: R. Culbert

For: METHOD OF CHEMICAL  
MECHANICAL POLISHING

**FAX RECEIVED**

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**GROUP 1700**

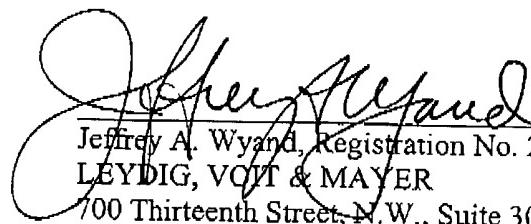
**RESPONSE TO NOTICE OF IMPROPER RCE**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Improper RCE appearing in the PAIR system, but never mailed, Applicant submits the claims section of the Amendment filed with the RCE, correctly indicating the status of all claims ever pending in this patent application.

Respectfully submitted,

  
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Date: November 15, 2004  
JAW:ves